PTO/SB/21 (05-03)

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TRAN			Applica	ition Number	10/660,813	
TRANSMITTAL FORM  (to be used for all correspondence after initial filing)			Filing C	Date	September 12, 2003	
			First N	amed Inventor	Mungekar, Hemant P.	
		Art Uni	t	Unassigned		
			Examir	ner Name	Unassigned	
Total Number of Pages in This Submission			Attorne	y Docket Number	A8067/T51700	
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Fee Transmittal Fo	orm	☐ Drawin	g(s)		After Allowance Communication to Group	
Fee Attached		Licens	ing-related	d Papers	Appeal Communication to Board of Appear and Interferences	
Amendment/Reply	y	Petition	n		Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)	
After Final			n to Conve ional Appl		Proprietary Information	
Affidavits/decl	laration(s)			ey, Revocation espondence Address	Status Letter	
Extension of Time			erminal Disclaimer		Other Enclosure(s) (please identify below):	
Express Abandonment Request		Request for Refund  CD, Number of CD(s)			Return Postcard, copy of ten (10) cited references	
Information Disclo	sure Statement					
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Response to Miss				I		
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or Individual	Patrick M. Bouche	er ————————————————————————————————————		Reg. N	o. 44,037	
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I hereby certify that this co as first class mail in an en	orrespondence is being evelope addressed to: 0	facsimile tran Commissioner	smitted to t for Patents	he USPTO or deposited w , P.O. Box 1450, Alexandr	rith the United States Postal Service with sufficient posia, VA 22313-1450 on the date shown below.	
Typed or printed nam	ne Nicole M. Wa	artell				
Signature Date 10/03/03					Date 10 03 03	

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Alexandria, VA 22313-1450

on OCT. 3.7 Company of

TOWNSEND and TOWNSEND and CREW LLP

Nicole M Wartell

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hemant P. Mungekar et al.

Application No.: 10/660,813

Filed: September 12, 2003

For: REACTIVE ION ETCHING FOR

SEMICONDUCTOR DEVICE FEATURE TOPOGRAPHY

**MODIFICATION** 

Examiner: Not yet assigned

Art Unit:

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. U.S. patents are not enclosed in accordance with the Patent Office waiver issued August 5, 2003 in the Official Gazette, which states as follows:

The Office hereby waives the requirement under 37 CFR 1.98

(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC 371



after June 30, 2003. See 37 CFR 1.491(b). For all patent applications filed on or before June 30, 2003, copies of cited U.S. patents and patent application publications are still required unless an eIDS is filed.

In accordance with 37 CFR 1.98(a)(2), copies of the foreign patent documents and non-patent literature references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Patrick M. Boucher Reg. No. 44,037

TOWNSEND and TOWNSEND and CREW LLP Two Embarcadero Center, 8<sup>th</sup> Floor San Francisco, California 94111-3834

Tel: 303-571-4000 Fax: 303-571-4321

PMB:nmb 60050521 v1 OCT 0 6 2003 PTO/SB/08A (08-03) te for form 1449A/PTO C mpl te if Kn wn **Application Number** 10/660,813 **INFORMATION DISCLOSURE** Filing Date September 12, 2003 STATEMENT BY APPLICANT First Named Inventor Mungekar, Hemant P. Art Unit (use as many sheets as necessary) **Examiner Name** Not yet assigned

Attorney Docket Number

A8067/T51700

Sheet

of | 3

	U.S. PATENT DOCUMENTS+						
Examiner Initials*	Cite No.1	Document Number  Number Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY		Patentee or ited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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	A41	US-6,013,584	01-11-2000	M'S			
Examiner Signature				Date Considered			

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## Substitute for form 1449A/PIU Substitute for form 1449A/PIU ADSTATEMENT BY APPLICANT

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2 Sheet of 3

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	Complete if Known	
Application Number	10/660,813	
Filing Date	September 12, 2003	
First Named Inventor	Mungekar, Hemant P.	
Art Unit		
Examiner Name	Not yet assigned	
Attorney Docket Number	A8067/T51700	

	U.S. PATENT DOCUMENTS+						
		Document Number					
Examiner Initials*	Cite No.1	Number Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
_	A42	US-6,030,881	02-29-2000	Papasouliotis et al.			
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Examiner	Cite	For	eign Patent Doc	ument		Name of Patentee or	Pages, Columns, Lines,	
Initials*	No.1	Country Code <sup>3</sup>	Number⁴	Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Applicant of Cited  Document	Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
	B1	JP	7-161703	Α	06-23-1995		Abstract only	
	B2	JP	2058836	Α	02-28-1990		Abstract only	
	В3	GB	2 267 291		12-01-1993			

Examiner Signature	Date Considered	

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INFORMATION PTO/SB/08B (08-03) Complete if Known Application Number 10/660,813 **INFORMATION DISCLOSURE** Filing Date September 12, 2003 STATEMENT BY APPLICANT First Named Inventor Mungekar, Hemant P. Art Unit (use as many sheets as necessary) Examiner Name Not yet assigned Sheet 3 3 Attomey Docket Number A8067/T51700

NON PATENT LITERATURE DOCUMENTS						
Examiner Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>			
	C1	ABRAHAM, "Reactive Facet Tapering of Plasma Oxide For Multilevel Interconnect Applications," VMIC Conference. pgs. 115-121 (1987).				
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	C6	QIAN et al., "High Density Plasma Deposition and Deep Submicron Gap Fill with Low Dielectric Constant SiOF Films," DUMIC Conference, pgs. 50-56, held in California (1995).				
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Examiner	Date	
Signature	Considered	

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